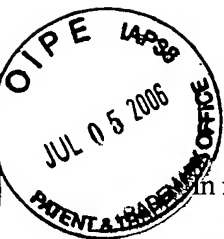


IFW/2818



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q83944

Hiroto OHTAKE, et al.

Appln. No.: 10/509,898

Group Art Unit: 2812

Confirmation No.: 2975

Examiner: Cheung LEE

Filed: October 1, 2004

For: SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 5, 2006, please amend the above-identified application as follows on the accompanying pages.

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